



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

RECEIVED  
JUL 20 2004  
TECH CENTER 2800

Applicant(s): Wayne G. Renken  
Title: Process Condition Sensing Wafer and Data Analysis System  
Application No.: 10/056,906 Filing Date: January 24, 2002  
Examiner: Charles D. Garber Group Art Unit: 2856  
Docket No.: SENS.005US0 Conf. No.: 2359

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

PETITION FOR EXTENSION OF TIME

Dear Sir:

Applicant(s) respectfully petition(s) for a three-month extension of time within which to respond to the outstanding Office Action mailed January 12, 2004, such extension allowing the undersigned until July 12, 2004 to respond.

A check is enclosed that includes the amount of \$475.00, as set forth in the enclosed transmittal letter.

EXPRESS MAIL NO.:

EV437667836US

Respectfully submitted,

*Peter Gallagher*  
Peter A. Gallagher  
Reg. No.47,584

*7/12/04*  
Date

1 07/15/2004 SSESHE1 00000034 10056906

01 FC:2801  
02 FC:2253

385.00-OP  
475.00 OP